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Bib Data Sheet

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## APPLICANTS

Hiroshi Sotozaki, Tokyo, JAPAN;

Koji Ato, Tokyo, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 10/283,154 10/30/2002 ABN  
 which is a DIV of 09/434,482 11/05/1999 PAT 6,494,985

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 10-316522 11/06/1998

JAPAN 11-138705 05/19/1999

JAPAN 11-236776 08/24/1999

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 10	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 1
Verified and Acknowledged Examiner's Signature	Initials				

## ADDRESS

000513  
 WENDEROTH, LIND & PONACK, L.L.P.  
 2033 K STREET N. W.  
 SUITE 800  
 WASHINGTON , DC  
 20006-1021

## TITLE

Method and apparatus for polishing a substrate

 All Fees